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Substitute for form 1449A/PTO		<b>Complete if Known</b>	
<b>INFORMATION DISCLOSURE STATEMENT BY APPLICANT</b> (use as many sheets as necessary)		Application Number	10/046,893
		Filing Date	January 17, 2002
		First Named Inventor	Osamu Nakamura et al.
		Group Art Unit	2823
		Examiner Name	H. Lee
Sheet 1 (List 1)	of 1	Attorney Docket Number	0756-2424



U.S. PATENT DOCUMENTS						
Examiner Initials*	Cite No. <sup>1</sup>	U.S. Patent Document		Name of Patentee or Applicant of Cited Document	Date of Publication of Cited Document MM-DD-YYYY	Pages, Columns, Lines, Where Relevant Passages or Relevant Figures Appear
		Number	Kind Code <sup>2</sup> (if known)			
Lee		6,204,154		Zhang et al.	03/20/2001	
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Examiner Signature	<i>Kevin Ming Lee</i>	Date Considered	12/31/03
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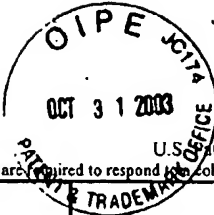
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				Group Art Unit	2823
				Examiner Name	H. Lee
Sheet	1 (List 2)	of	4	Attorney Docket Number	0756-2424



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Examiner Signature	Kun Ming Lee			Date Considered	12/31/03	

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Examiner Signature	H. Lee			Date Considered	12/31/03



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